Design of Photonic Crystal Nanocavity With $Q$-Factor of $\sim 10^9$

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Invited Paper

Abstract—Photonic crystal nanocavities are expected to make great contributions in areas of physics and engineering such as the slowing and stopping of light and optical quantum information processing. We first review approaches to the goal of increasing the quality factor of two-dimensional photonic crystal nanocavities. Losses from a cavity can be suppressed, with a consequent increase of the quality factor, by containing the electromagnetic field in the form of a Gaussian envelope function. We then propose a new method of analytical cavity design, based on the detailed investigation of waveguide modes, in order to realize Gaussian cavity mode fields. This has enabled us to achieve a quality factor of $\sim 10^9$ while maintaining a cavity volume of one cubic wavelength.

Index Terms—Analytic continuation, design, Gaussian, modal volume, nanocavity, photonic crystal, $Q$ factor, resonator.

I. INTRODUCTION

TWO-DIMENSIONAL (2D) photonic crystal (PC) nanocavities [1]–[9] are currently the focus of much interest because they are able to strongly confine photons within a tiny space. Even though these cavities have modal volumes of as small as a cubic wavelength, theoretical quality ($Q$) factors more than 10 000 000 have been designed [3]–[5]. Correspondingly, the experimental $Q$-factor more than 2 000 000, the highest recorded value for any photonic crystal thus far, has been achieved [6], [7]. Moreover, dynamic control of such high $Q$-factor of a nanocavity has recently been both proposed and demonstrated [10]. It is expected that nanocavities will be applied to various areas of physics and engineering such as the slowing and/or stopping of light [10], [11], ultimate nanolasers [9], [12], [13], ultra-compact filters [14]–[16], and quantum information processing [6], [17], [18].

In order to realize high-$Q$ cavities in a 2D PC, the main issue to consider is how strongly the photons can be confined in the out-of-plane direction by total internal reflection (TIR). We have previously reported an important design concept for the realization of high-$Q$ nanocavities: to suppress radiation loss, the envelope of the cavity mode field should be a Gaussian function [1], [2], [3], [6]. In this paper, we first explain the relationship between the Gaussian mode field and the $Q$ factor, and review the design and characteristics of the cavities that we have developed. We then discuss a new analytical design for the realization of a Gaussian mode field by investigating the dispersion curve of the PC waveguide. Finally, we show the results of simulations for a cavity with a theoretical $Q$-factor of almost $10^9$ developed using this design concept.

II. REVIEW OF IMPORTANCE OF GAUSSIAN CONFINEMENT TO ACHIEVE HIGH-$Q$-FACTOR

In a 2D PC nanocavity, three-dimensional (3D) photon confinement is achieved using the photonic band gap (PBG) effect for the in-plane direction and by TIR for the vertical direction. Although perfect confinement within the in-plane direction can easily be achieved by using a sufficient number of PC periods, confinement of the localized mode in the out-of-plane direction is generally incomplete. Therefore, the most important issue to be addressed is how strongly the photons can be confined by TIR.

Initial designs used the combination of a donor-type defect, which consists of buried lattice points for the purpose of increasing the degree of TIR [19], [20], and a cavity with a gradual change of lattice point radius [21]. However, no clear direct design rules for improving the $Q$-factor were laid down until 2003, when we proposed the concept of Gaussian confinement [1]. In order to explain the way in which this mechanism is able to suppress losses, we consider the one-dimensional cavity shown in Fig. 1(a), whose structure is assumed to be uniform in the $y$ direction, normal to the paper. The model cavity consists of a dielectric material with finite length ($x$ direction) and thickness ($z$ direction); perfect mirrors enclose the cavity on both sides. We consider two extreme cavities with the same size and resonant wavelength, but different in-plane confinement characteristics. Photons in the first cavity are confined by sharp reflection at the cavity edges, giving a cavity mode electric field profile with a rectangular envelope function [Fig. 1(b)]. In the second cavity, photons are confined by spatially distributed reflection, such that the electric field profile of the cavity mode has a Gaussian envelope function [Fig. 1(c)]. These electric field...
profiles are taken along the interfaces between the slabs and cladding (air) of the cavities, but each profile is valid for all z-positions inside its respective cavity. The real space coordinate is given in units of the wavelength of the resonant mode inside the cavity (λ). Fig. 1(d) and (e) show the spatial Fourier transform (FT) spectra of each electric field profile, which represent the plane wave components of the cavity mode. The horizontal axis represents the wavevector tangential to the interface (k_y/λ). The wavevector of light propagating through the cladding is k_0; only plane wave components with |k_y/λ| > k_0 can be confined by TIR. The gray regions in Fig. 1(d) and (e) represent the region where |k_y/λ| < k_0, that is, the “leaky region,” where the plane wave components of a cavity mode are radiated into the cladding. It is apparent that the cavity with the rectangular envelope function [Fig. 1(b) and (d)] has a greater plane wave component inside the leaky region than the cavity with the Gaussian envelope function [Fig. 1(c) and (e)].

Understanding the difference between the two types of cavity modes is considered to be vital for the realization of high-Q photonic nanocavities. We analyzed the cavity mode electric field profiles by separating them into a fundamental sinusoidal wave with a wavelength of λ and an envelope function. The mode field profile is then expressed as the product of the fundamental wave and the envelope function in real space, while the FT spectrum of the mode field profile is described by a convolution of the FT spectra of the fundamental wave and the envelope function. The FT of the fundamental wave gives two delta functions at k_y/λ = ±2π/λ, and the FT of the envelope gives a function of finite width that depends on its shape in real space. Since the FT of the fundamental wave is outside the leaky region, the component within the leaky region is generated by the convolution with the envelope spectrum. The convolution of the two delta functions and the envelope spectrum is the sum of two envelope spectra, shifted by +2π/λ and −2π/λ. Therefore, the higher spatial frequency components of the envelope spectrum, with (2π/λ − k_0) < |k_y/λ| < (2π/λ + k_0), are transferred to the leaky region. The FT mode electric field profile associated with the rectangular envelope function [Fig. 1(b) and (d)] has a large component in the higher spatial frequency region, due to the abrupt changes in the envelope function at both edges. This results in large radiation losses. In contrast, the mode electric field profile associated with the Gaussian envelope function [Fig. 1(c) and (e)] has only a small component in the higher spatial frequency region, due to the smooth variation of the envelope function in real space. Therefore, only small radiation losses are suffered. It is clear that the shape of the envelope function has a critical effect on the radiation loss of the model cavity and that abrupt changes in the envelope function should be avoided in order to obtain high Q-factors. The confinement of light within regions with dimensions of the order of optical wavelengths requires a spatially localized envelope function of the same dimensions. In order to realize a high-Q photonic nanocavity, the envelope function should be spatially localized but have no high-frequency components. As shown here, a Gaussian function can fulfill both these requirements and thus a Gaussian function is practically ideal function for designing a high-Q photonic nanocavity.

On the basis of the above considerations, we designed a high-Q photonic nanocavity in a 2D PC based on the L3 cavity shown in Fig. 2(a), which was created by burying three air rods in a line along the Γ − J direction (parallel to the x-direction in this structure). The thickness of the slab, the radius of the air rods and the refractive index of the slab were 0.66λ, 0.29λ and 3.4, respectively. The electric field profile, E_y, of the fundamental mode of the cavity was calculated using the 3D finite-difference time-domain (FDTD) method, and is shown in Fig. 2(b). To simplify the analysis of the calculated profile, we focused on E_y for the centerline of the cavity along the x-direction in real space [solid line in Fig. 2(a)]. We fitted the mode field profile using a curve corresponding to the product of a sinusoidal wave, with a wavelength the same as that of the fundamental wave of the E_y profile, and a Gaussian function [dashed line in Fig. 2(b)]. The fitted curve closely matches E_y near the center of the cavity, but at the edges of the cavity [indicated by dashed circles in Fig. 2(b)], the envelope of E_y decreases more rapidly than the Gaussian function.

In order to bring the cavity mode profile closer to the ideal Gaussian function, the air-holes at the cavity edges were shifted to lay 0.2λ outside the cavity [1]. The resulting cavity structure and calculated electric field distribution are shown in Fig. 2(c). The E_y profile along the centerline [solid line in Fig. 2(c)] is shown in Fig. 2(d) together with the fitted curve, generated in the same manner as described above. This structural adjustment resulted in weaker reflection at the cavity edges, as the periodicity of the air holes is disturbed. Therefore, the PBG effect is also expected to be weakened. As shown in Fig. 2(d), the electric field profile of the modified cavity is closer to the Gaussian curve than that of the original cavity without displacement of air-holes. The calculated Q-factor of the cavity shown in Fig. 2(c) is 100 000, which is 20 times larger than that of the cavity with no air hole shifts. We fabricated this cavity and obtained an experimental Q-factor of 45000.
In 2005, we proposed the concept of “photonic multiheterostructures” as a more comprehensive method to tune the envelope function of a cavity [3]. In Fig. 3(a), three PCs (0, 1 and 2) with a common line defect are joined to form a double heterostructure. The lattice constants of PC0 ($a_0$), PC1 ($a_1$) and PC2 ($a_2$) are in the order $a_0 > a_1 > a_2$. The transmission frequency range of the line defect varies with the lattice constant [Fig. 3(b)], ensuring that light with a frequency slightly above the mode edge of PC1 becomes a propagation mode in the line defect in both PC0 and PC1 and is in the mode-gap region of the waveguide, where the propagation mode does not exist but evanescent modes can be excited. The calculated electric-field distribution of the photonic double-heterostructure cavity and its profile along the waveguide direction are shown in Fig. 3(c) and (d), respectively. The calculation was performed using the 3-D FDTD method, where the lattice constants of PCs 0, 1 and 2 were $a_0 = 420$ nm, $a_1 = 415$ nm, and $a_2 = 410$ nm, respectively, and the slab thickness was $0.6a_0$. In Fig. 3(d), the solid and dashed lines indicate the calculated electric field distribution and the fitted curve, generated as described above, respectively. The electric field profile of the photonic multiheterostructure cavity lay very close to the ideal Gaussian curve. For an air hole radius of 0.26 $a_0$, the maximum theoretical $Q$-factor exceeded 24,000,000 and the modal volume of the cavity was $\sim 1.2(\lambda_0/n)^3$. We have recently succeeded in fabricating this type of photonic multiheterostructure nanocavity, achieving a $Q$-factor of more than $2 \times 10^7$ by careful optimization of the fabrication process [6], [7]. This represents the
highest recorded experimental $Q$-factor for any PC nanocavity to date. Note that this concept of multiheterostructure cavity has various variations. For example, waveguide widths’ modulation [5] instead of lattice-constant modulation can be utilized to achieve the band structure as shown in Fig. 3(b).

III. NEW DESIGN FOR REALIZATION OF GAUSSIAN MODE FIELD WITH $Q$-FACTOR OF $10^9$

In Section II, we demonstrate that a cavity mode field with a Gaussian envelope is the key requirement for realizing a high-$Q$ photonic nanocavity, and we describe a multiheterostructure nanocavity that fulfills the necessary conditions. However, the analytical design rule for obtaining a Gaussian mode field has not been discussed. In this section, we develop a straightforward, analytical cavity design that produces Gaussian mode fields by studying the dispersion curve of a PC waveguide. The Gaussian mode field is of the form $\exp(-Bx^2)$, where $x$ represents the distance from the center of the cavity, and $B$ is a constant. To realize this mode shape, we consider building a cavity that uses the mode-gap region of PC waveguides. The evanescent mode field in the mode-gap region diminishes exponentially and can be expressed as $\exp(-(q\xi))$, where $q$ is the imaginary part of wavevector $k$ ($q = \text{Im}(k)$), which gives the decay of the mode field. Therefore, the condition

$$q = Bx \quad (1)$$

should be satisfied for a Gaussian mode field. That is, $q$ should be proportional to $x$.

For the design of this cavity, the dispersion diagram of the mode-gap region of the waveguide is required, and is calculated in Section III-A. In Section III-B, a cavity with a Gaussian mode field is designed according to the calculated dispersion diagram. In Section III-C, the properties of the cavity are investigated using FDTD calculations.

A. Dispersion of Evanescent Wave in Photonic Crystal Waveguide

The dispersion diagram of the evanescent wave near the band edge can be derived from the extension of the dispersion curve of the allowed band (waveguide mode) using the analytic continuation method [22], [23]. Fig. 4(a) shows a schematic picture of a waveguide of width $W = \sqrt{3}a$, which corresponds to one buried row of air holes in the $\Gamma - J$ direction. The waveguide width $W$ is defined as the distance between the centers of the air holes in the rows on each side of the waveguide. The radius of the air holes is $0.29a$ and the slab thickness is $0.6a$. The dielectric slab is assumed to be composed of silicon ($n = 3.4$). The dispersion relation of a propagation mode of this waveguide, calculated using the 3D FDTD method, is shown in Fig. 4(b). This dispersion function can be fitted using a Taylor series expansion of the term $(k - 0.5)$. We consider only the even-order

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Fig. 4. (a) Schematic picture of a waveguide with width $W = \sqrt{3}a$. (b) Calculated dispersion relation of a propagation mode for waveguide in (a). (c) Dispersion relation of the mode-gap, calculated from (b). (d) Schematic picture of a PC1 waveguide with width $W = 0.62 \times \sqrt{3}a$. (e) Calculated dispersion relation of a propagation mode for waveguide in (d). (f) Dispersion relation of the mode-gap, calculated from (e).
The fitted function is expressed as
\[ f = 0.263 + 0.01(k - 0.5)^2 + 2.5(k - 0.5)^4 + 200(k - 0.5)^6. \]  
(2)

It is apparent that not only the second-order term \((k - 0.5)^2\) but also fourth- and sixth-order terms are necessary to fit the dispersion curve near the mode-edge frequency. This is because the slope of the dispersion curve near the mode-edge is unusually small, due to the fact that the guiding mechanism of this waveguide is not refractive index guiding but rather PBG guiding. The imaginary dispersion relation for the mode-gap region can then be derived using the analytic continuation method by substituting the complex wavevector \( k = 0.5 + iq \) into (2). The resulting dispersion curve in the mode-gap region is shown in Fig. 4(c) and is expressed as
\[ f = 0.263 - 0.01q^2 + 2.5q^4 - 200q^6. \]  
(3)

This is not a parabolic function but is similar to a step function. Although such a step-like dispersion curve allows a double-heterostructure cavity with a small modal volume and a small variation in lattice constants, the function is too complex to enable straightforward analytic cavity design.

In order to obtain a simpler dispersion curve, we adopt a waveguide with refractive index guiding, as is present in conventional dielectric waveguides. We consider the waveguide shown in Fig. 4(d), which differs from that in Fig. 4(a) only in width \((W = 0.62 \times \sqrt{3} a)\) [23]. The dispersion relation of the propagation mode of this waveguide was calculated using a similar procedure to that described above, and is shown in Fig. 4(e). It can be fitted by the function
\[ f = 0.263 + 0.94(k - 0.5)^2. \]  
(4)

Unlike (1), only the second-order term in \((k - 0.5)^2\) is necessary to fit the dispersion relation of this propagation mode. This is because refractive index guiding is the relevant mechanism here, as found in conventional dielectric waveguides. Substituting \( k = 0.5 + iq \) into (4), the complex dispersion relation of the waveguide in the mode-gap region is obtained and expressed as
\[ f = 0.263 - 0.94q^2. \]  
(5)

This parabolic function is shown in Fig. 4(f), and enables simpler analytic cavity design.

B. Multiheterostructure Cavity Design for Realization of Gaussian Mode Field Using Refractive Index Guiding Waveguide

We will now discuss the analytic design of nanocavities possessing a Gaussian mode field by using the dispersion curve in the mode-gap region obtained in Section III-B. For the realization of a high-Q nanocavity, \( q \) should be
\[ q = Bx \]  
(6)
as shown in Section III-A. The damping factor of the waveguide in the mode-gap region can then be derived by substituting \( f = f_{\text{cav}} \) in (5)
\[ f_{\text{cav}} = f_{\text{cut}} - Aq^2. \]  
(7)

Here, \( f_{\text{cav}} \) is the cutoff frequency of the waveguide \((f_{\text{cav}} = 0.263 c/a)\) and \( A \) is a constant \((A = 2.5)\). Combining (6) and (7) gives
\[ f_{\text{cav}}(x) = f_{\text{cav}} - AB^2x^2. \]  
(8)

Fig. 5. (a) Schematic picture of multiheterostructure nanocavity based on refractive index guiding waveguide. (b) Schematic picture of the band diagram along the waveguide direction.
Here, $f_{\text{cut}}(x)$ is the cutoff frequency at position $x$. This implies that the cutoff frequency is variable, which can be achieved by use of the multiheterostructure shown in Fig. 5(a). Five different lattice constants are used in this structure: PC0 extends over 3 lattice constants, PC1 to PC4 each extend over 2 lattice constants, and PC5 is considered to be semi-infinite in length. The band structure of this defect should be Fig. 5(b), where $\{ f_{\text{cut}}(x) - f_{\text{cav}} \}$ is proportional to the square of $x$.

The cutoff frequency $f_{\text{cut}}$ is inversely proportional to the lattice constant because the operating wavelength of a PC, including the cutoff wavelength, is proportional to the lattice constant. Therefore, the cutoff frequency $f_{\text{cut}}(x)$ and the lattice constant $a(x)$ at a position $x$ should satisfy

$$f(x)_{\text{cut}} = \frac{a_0}{a(x)} f_0^{\text{cut}}$$

where $f_0^{\text{cut}}$ and $a_0$ represent the cutoff frequency and lattice constant of PC0, respectively. By assuming that the resonant frequency of the designed cavity $f_{\text{cav}}$ is equal to $f_0^{\text{cut}}$, $a(x)$ can be derived from (8) and (9) as

$$a(x) = \frac{a_0}{1 + AB^2 x^2 / f_0^{\text{cut}}}$$

When the condition $(AB^2 x^2 / f_0^{\text{cut}}) << 1$ is satisfied

$$a(x) = a_0 \left( 1 - AB^2 x^2 / f_0^{\text{cut}} \right).$$

As shown in Fig. 5(a), the distance $x_n$ between the center of the cavity and the center of PC$_n$ for $n = 1$ to 4 can be approximated as

$$x_n = (2n + 1/2)a_0$$

by assuming that the change in lattice constants is small. Substituting (12) into (11) gives

$$a_n = a_0 \left[ 1 - 4AB^2 a_0^2 (n + 1/4)^2 / f_0^{\text{cut}} \right].$$

Taking $C = 4AB^2 a_0^2 / f_0^{\text{cut}}$, this expression can be simplified to

$$a_n = a_0 \left[ 1 - C(n + 1/4)^2 \right],$$

(14)

Equation (14) gives us the required lattice constants for each PC$_n$ ($n = 1$ to 5) in order to realize a cavity with a Gaussian mode field.

C. FDTD Analysis of Newly Designed Multiheterostructure Nanocavity

We carried out 3D FDTD calculations for a cavity with $C = 1.45 \times 10^{-3} (a_1 = 0.998 a_0, a_2 = 0.993 a_0, a_3 = 0.985 a_0, a_4 = 0.974 a_0, a_5 = 0.960 a_0)$. The cell size in the FDTD calculation is set to be $0.1a_0$. The $Q$ factor is calculated by the ratio of the electromagnetic energy in the cavity and flux of energy exiting the cavity to free space. The slab thickness was $0.6a_0$ and the air hole radius $0.25a_0$, as before. The calculated $E_y$ field is shown in Fig. 6(a) and the profile along the centerline $[\text{parallel to } x]$, the solid line in Fig. 6(a) is shown in Fig. 6(b). The envelope of the mode field matches the Gaussian function very closely. The calculated $Q$-factor and the modal volume are $5 \times 10^6$ and $1.3(\lambda / n)^3$, respectively, which corresponds to a 25-fold increase of the theoretical $Q$-factor while maintaining the same modal volume. By comparing Fig. 6(a) with Fig. 3(c), it is apparent that the mode field of the new cavity extends further along the $x$-direction (parallel to the waveguide), which is expected to result in the suppression of losses from the cavity. Moreover, the mode field extension in the $y$-direction is smaller in the new cavity because the guiding mechanism is based on refractive index guiding, leading to the same modal volume as in the previous multiheterostructure nanocavity design, despite the extension of the mode field in the $x$-direction. Fig. 6(c) shows the calculated 2D FT of electric field of this cavity, which clearly shows that almost no components exist inside the leaky region. The small mode field extension in the $y$-direction leads to the extension of the FT components in the $k_y$ direction. However, this does not cause...
the peaks to shift along $k_F$, and thus the shape of the mode along the $y$ axis is not a major influence on $Q$ factor. The higher-order mode of this cavity is shown in Fig. 7 beside the fundamental mode and band diagram. The free spectral range of this cavity is shown in Fig. 7. The free spectrum range is calculated to be 40 nm when the resonant wavelength is about 1.5 $\mu$m.

This cavity has a theoretical photon lifetime of $\sim 1.5\mu$s and can thus potentially be applied to a range of technologies, including an optical buffer memory for optical telecommunications.

**REFERENCES**


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